



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

WILLIAM D. ROCHE
DAVID D. WU
MASSUD AMINPUR
SCOTT D. LUNING

Serial No.: 09/676,197

Filed: September 28, 2000

For: METHOD OF FORMING A GATE

**ELECTRODE ON A SEMICONDUCTOR** 

DEVICE AND A DEVICE INCORPORATING SAME

Examiner: K. Duong

Group Art Unit: 2822

Att'y Docket: 2000.032200/TT3634

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OCT -9 2002

**RESPONSE TO OFFICE ACTION DATED JULY 31, 2002** 

CERTIFICATE OF MAILING 37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date below:

September 30, 2002

Date

Signature

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

This paper is submitted in response to the Office Action dated July 31, 2002, for which the three-month date for response is October 31, 2002.

It is believed that no fee is required in connection with this response. However, the Assistant Commissioner is authorized to deduct any fees required under 37 C.F.R. §§ 1.16 to 1.21 from the Advanced Micro Devices, Inc. Deposit Account No. 01-0365/TT3634.

Reconsideration of the application is respectfully requested.

